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| Form PTO-1449<br>(REV. 7-80)   | U.S. DEPARTMENT OF COMMERCE<br>PATENT AND TRADEMARK OFFICE | Atty. Docket No.<br><br>13171 (YO999-509) | Serial No.<br><br>Unassigned |
| LIST OF PRIOR ART<br>CITED BY APPLICANT<br><br>(Use several sheets if necessary) |  | Applicants<br>Cyril Cabral, Jr., et al.   |                              |
|  |  | Filing Date<br><br>Herewith               | Group<br><br>Unassigned      |

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**U.S. PATENT DOCUMENTS**

| EXAMINER<br>INITIAL* |    | DOCUMENT NUMBER | DATE     | NAME               | CLASS | SUBCLASS | FILING DATE<br>(if appropriate) |
|----------------------|----|-----------------|----------|--------------------|-------|----------|---------------------------------|
| EK                   | AA | 5,510,295       | 4/23/96  | Cabral, Jr. et al. | —     | —        | —                               |
| EK                   | AB | 5,608,226       | 3/4/97   | Yamada et al.      | —     | —        | —                               |
| EK                   | AC | 5,624,869       | 4/29/97  | Agnello et al.     | —     | —        | —                               |
| EK                   | AD | 5,828,131       | 10/27/98 | Cabral, Jr. et al. | —     | —        | —                               |
|                      | AE |                 |          |                    |       |          |                                 |
|                      | AF |                 |          |                    |       |          |                                 |
|                      | AG |                 |          |                    |       |          |                                 |
|                      | AJ |                 |          |                    |       |          |                                 |

**FOREIGN PATENT DOCUMENTS**

|  |    | DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUBCLASS | TRANSLATION |    |
|--|----|-----------------|------|---------|-------|----------|-------------|----|
|  |    |                 |      |         |       |          | YES         | NO |
|  | AK |                 |      |         |       |          |             |    |
|  | AL |                 |      |         |       |          |             |    |

**OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)**

|    |    |  |
|----|----|--|
| EK | AN | M. Lawrence, et al., "Growth of Epitaxial CoSi <sub>2</sub> on (100)Si," Appl. Phys. Lett., Vol. 58, No. 12, pp. 1308-1310 (1991).   |
| EK | AO | C. Cabral, et al., "In-Situ X-Ray Diffractin and Resistivity Analysis of CoSi <sub>2</sub> Phase Formation With and Without a Ti Interlayer at Rapid Thermal Annealing Rates," Mat. Res. Soc. Symp. Proc., Vol. 375, pp. 253-258 (1995). |
|    | AP |  |

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| EXAMINER<br><i>Erik Karl</i> | DATE CONSIDERED<br>7/10/02 |
|------------------------------|----------------------------|

\* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.